

Notice of References Cited	Application/Control No. 10/016,009	Applicant(s)/Patent Under Reexamination ARVIN ET AL.	
	Examiner Roberts Culbert	Art Unit 1763	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,435,398	08-2002	Hartfield et al.	228/103
	B	US-			
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	D	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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